

Notice of References Cited	Application/Control No. 10/564,675		Applicant(s)/Patent Under Reexamination COSMA ET AL.	
	Examiner Aaron Williams		Art Unit 2889	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,929,558 A	07-1999	Lee, Sun-heang	313/402
*	B	US-6,064,146 A	05-2000	Lee, Sun-heang	313/407
*	C	US-2001/0011864 A1	08-2001	Nose et al.	313/407
*	D	US-2002/0036457 A1	03-2002	Kim et al.	313/407
*	E	US-2002/0145375 A1	10-2002	LaPeruta et al.	313/402
*	F	US-2002/0167259 A1	11-2002	Kim, Yong Kun	313/407
*	G	US-2003/0001484 A1	01-2003	Reed et al.	313/407
*	H	US-2003/0230963 A1	12-2003	Lee et al.	313/407
*	I	US-2004/0189179 A1	09-2004	Karita et al.	313/407
*	J	US-2003/0080666	05-2003	Gorog et al.	313/407
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP0709872	04-1999	European Patent	Maki et al.	H01J 29/07
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.